Investigating and Correlating Photoelectrochemical, Photocatalytic, and Antimicrobial Properties of TiO2 Nanolayers

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Investigating and correlating photoelectrochemical, photocatalytic, and antimicrobial properties of TiO$_2$ nanolayers

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ABSTRACT

Semiconducting transition metal oxides such as TiO$_2$ are promising photo(electro)catalysts for solar water splitting and photoreduction of CO$_2$. Titania admixtures are also used in paints and building materials or as coating on window glass and medical devices, giving the modified materials antimicrobial, self- or even air-cleaning properties. Although TiO$_2$ is an effective catalyst for all these applications, it is mechanistically important to distinguish between photoelectrocatalytic, photocatalytic and antimicrobial processes. In the former, TiO$_2$ is usually electrically contacted as photoanode, i.e. only the oxidation reaction takes place at the titania surface. In the two latter applications, TiO$_2$ works as heterogeneous catalyst and has to catalyze a complete redox cycle. The underlying common and diverging rate-determining photochemical and photoelectrochemical mechanisms are still not well understood. Here, we thus present a systematic structural, photoelectrocatalytic, photocatalytic and antimicrobial study to directly compare and correlate these properties. We prepared TiO$_2$ thin films on flourine-doped tin oxide (FTO) substrates by a sol-gel spin-coating technique. The materials were annealed at temperatures between 200 and 600$^\circ$C and their morphologies were studied by GIXRD, FESEM and EDX. Photoelectrocatalytic properties were measured by linear sweep voltammetry, photoelectrochemical impedance spectroscopy, chopped light chronoamperometry, and intensity modulated photocurrent/ photovoltage spectroscopy. For comparison, photocatalytic rate constants were determined by methylene blue and Escherichia coli degradation and correlated with the deduced photoelectrocatalytic parameters.

Introduction

At least since the pioneering work of Fujishima and Honda in 1972$^{1,2}$ semiconducting transition metal oxides such as titanium dioxide (TiO$_2$) are intensively studied as photoanode and photocatalyst materials for photosplitting of water with ultraviolet (UV) light$^3$. Recently reported record-high quantum efficiencies between 81.8 % at 437 nm and 3.2 % at 1000 nm of N-TiO$_2$ even opens up completely new vistas to utilize nearly the whole solar spectrum beyond the UV range for photo(electro)catalytic applications$^4$. Moreover, TiO$_2$ can photocatalytically reduce CO$_2$ to useful chemicals under sun light irradiation$^5,6$ making it a promising platform for a carbon-neutral energy and raw material economy. Photocatalytic water splitting by TiO$_2$ induces highly reactive intermediate species such as hydroxyl radicals (HO$^\bullet$), hydroperoxyl radicals (HOO$^\bullet$), and superoxide radical anions (O$_2^{\cdot-}$)$^7$. These species react very effectively with oxidizable organic or biologic components converting them to CO$_2$ and H$_2$O. As a consequence, this property of TiO$_2$ enables many more interesting applications. One example is the photocatalytic treatment of waste water with dispersed or immobilized TiO$_2$ under UV light$^8,9$. Moreover, glassy surfaces coated with a polycrystalline titania film exhibit excellent anti-fogging and self cleaning properties under irradiation$^{10}$. In addition to these super-hydrophilic properties, the photocatalytic oxidation of organic and inorganic contaminations and the antimicrobial effect of titanium dioxide have been utilized to develop materials and surfaces avoiding the coverage by algae, moss, mold, bacteria etc.$^{11-13}$ Additionally, photoactive building materials such as cobblestones, roof tiles and concrete walls containing or coated with TiO$_2$ are being tested in street tunnels to photocatalytically reduce the NO$_x$ content of ambient air$^{14}$. TiO$_2$ is one of the most promising candidates as catalyst for the aforementioned applications, because it is characterized by a high exciton binding energy, it is unsoluble in aqueous liquids, chemically and biologically inert, photostable, not toxic, relatively cheap and abundant$^{8,15,16}$. The various modifications of TiO$_2$ can be prepared in many different forms such as nanoparticles, nanotubes, nanofibers, nanocubes etc., but also as composite and hybride material - e.g. in combination with polymers or carbon nanomaterials - by comparably cheap methods$^{17}$. Layers of TiO$_2$ have been prepared, e.g., by sol-gel spin- or dip coating methods, thermal oxidation of titanium sheets, spray pyrolysis, chemical vapor deposition, pulsed laser deposition, or magnetron sputtering techniques$^{8,18}$.

There is broad agreement in the scientific community that the photocatalytic reaction rate for the different reaction schemes...
is adversely affected by a radiative or non-radiative recombination of photo-excited charge carriers\textsuperscript{10–21}. However, it is very often not clear, if a fast electron-hole recombination or a slow charge diffusion to the reactive surface is the limiting factor for the reaction rate. Most known forms of TiO\textsubscript{2} are characterized as n-type semiconductors, which is often attributed to an easy release of oxygen leaving electrons as majority charge carriers in the lattice. These electrons can be trapped in the lattice as Ti\textsuperscript{3+} and released again as Ti\textsuperscript{4+} (lattice) + e\textsubscript{CB}, where e\textsubscript{CB} is a free electron in the conduction band. Such donor sites can also act as effective electron-hole recombination center. On the other hand, photo-excited holes in the valence band, h\textsubscript{VB}, can be trapped as O\textsuperscript{2–} in the lattice and released again as O\textsuperscript{2–} (lattice) + h\textsubscript{VB}. The O\textsuperscript{2–} site is also considered as possible recombination center. However, shallow donor sites for electrons (or acceptor sites for holes) with energies just below the conduction band minimum (just above the valence band maximum), where thermal energy is sufficient to lift the charge carriers into the bands, may give rise to a fast charge transfer process. In contrast, deep donor or acceptor states decrease the charge transfer rate since the electron hopping between deep traps is usually slower than migration through the conduction band and shallow traps, thus enhancing the possibility for a charge carrier recombination process.

In Figure 1 energy diagrams of a photocatalytically active n-type semiconductor particle with depletion zone for photocatalytic and photoelectrochemical processes, respectively, as described by Gerischer\textsuperscript{22}, and the most important transfer and recombination processes with their corresponding rate constants as suggested by Ponomarev and Peter\textsuperscript{23} are schematically summarized. In this model the absorption of light induces a flux of holes toward the semiconductor-electrolyte interface and of electrons to the back-contact (or to the other side of the semiconductor particle). The charge transfer efficiency is limited by a competition between hole transfer from the semiconductor to the electrolyte and the recombination of holes with electrons from the conduction band. Holes can be directly transferred via the valence band (with rate constant \(k_1\)), react with electrons in surface states (\(k_2\)), or can be transferred to the electrolyte via surface states (\(k_3\)). Electrons can be transferred via the conduction band to the back-contact or they can be captured in surface states with rate constant \(k_4\) acting again as recombination sites. In addition, direct band to band electron-hole recombination or recombination at defects in the bulk are possible, but usually less likely than surface recombinations. The complexity increases even more, if different phases, dopants, artificial defects etc. are to be included\textsuperscript{3}.

![Energy schemes for a photocatalytically active n-type semiconductor particle (a) and a photoelectrochemical cell with an n-type semiconductor electrode as photoanode (b) with depletion layer, interfacial semiconductor-electrolyte charge transfer, and possible redox reactions. c) Schematic band diagram with charge transfer rate constants and equivalent circuit elements used to fit EIS data.](image)

Many attempts have been made to study and quantify the aforementioned charge transport processes. With pump-probe spectroscopy the charge generation and recombination processes in TiO\textsubscript{2} were analyzed on a femtosecond time scale\textsuperscript{10,24}. However, it turned out that the high photon flux of a femtosecond pulse induced second order kinetics and very fast recombination rates that might not reflect the situation in a semiconductor under "normal" light intensities. Alternatively, the measurement of transient photocurrents with chopped light chronoamperometry (CLCA) under potentiostatic conditions was utilized to deduce surface recombination rate constants. Moreover, photoelectrochemical methods such as intensity modulated photocurrent spectroscopy (IMPS), intensity modulated photovoltage spectroscopy (IMVS), and photoelectrochemical impedance spectroscopy (PEIS) under controlled light intensity radiation proved to be powerful tools for deducing electron and hole lifetimes and rate constants for charge transfer and recombination\textsuperscript{20,21,23–25}. Apart from these electrochemical methods the photoactivity of semiconducting powders and films has been very often analyzed by photometrically monitoring the photocatalyzed degradation of organic dyes such as methylene blue\textsuperscript{26}. An established procedure to describe the antimicrobial photoactivity comprehends the determination of the degradation rate for bacterial cultures on the surface of a photocatalyst under irradiation\textsuperscript{27,28}.

However, direct links rationally connecting photoelectrochemical, photocatalytic and antimicrobial properties of TiO\textsubscript{2} coatings are still missing and shall be provided by the present work. We hence prepared TiO\textsubscript{2} films via a well reproducible hydrothermal sol-gel route and a spin-coating process. Quartz glass slides coated with fluorine-doped tin oxide (FTO) were used.
as substrates to realize a sufficient conductivity for photoelectrochemical measurements. Samples were annealed at temperatures between 200 and 600°C to obtain various amorphous and crystalline titania phases with different photo(electro)catalytic properties. The morphology and crystallinity of the films was analyzed by grazing incidence X-ray diffraction (GIXRD) and field emission scanning electron microscopy (FESEM) in combination with energy dispersive X-ray spectroscopy (EDX). The photoactivity of the samples towards organic and biologic counterparts under UV light was measured by the degradation of methylene blue (MB) and Escherichia coli (E. coli) bacteria, respectively. Degradation rates were correlated with kinetic and electrochemical parameters as obtained by IMVS, IMPS, PEIS, linear sweep voltammetry (LSV), and CLCA.

Results

Structural characterization

XRD analysis

The structural characterization of nanolayers on crystalline substrates is usually a challenging task due to the very low signal intensities and strong interferences with the dominating substrate. We hence chose to execute GIXRD to increase the surface sensitivity of the measurement. However, it turned out that the reflections due to the cassiterite structure of the FTO sublayer still dominated the whole diffractogram making it impossible to deduce any information on the TiO\textsubscript{2} layers (Figure 2a).

![GIXRD patterns](image)

**Figure 2.** GIXRD patterns of TiO\textsubscript{2} thin films coated on the FTO side (a) and on the reversed non-FTO coated side of a quartz glass (b-e), respectively. Samples were calcined at the indicated temperatures. The diffraction pattern of the SnO\textsubscript{2} modification cassiterite (a) and the TiO\textsubscript{2} modification anatase (b-e), respectively, are displayed as vertical lines for comparison.

We thus alternatively prepared TiO\textsubscript{2} nanolayers annealed at 300, 400, 500, and 600°C, respectively, after the same protocol as described for the FTO-coated samples, but with the exception that the layers were spin-coated on the opposite, i.e. FTO-free.
side of the glass slides. Now, a very broad signal peaking at about 24° with a broad shoulder at about 42° can be observed in the diffractograms - features that are characteristic for the amorphous silica phase of the quartz glass substrate (Figure 2b-e). As for the TiO₂ nanolayers annealed at 300°C and 400°C, respectively, no further unambiguous features or peaks could be identified. In contrast, two small but distinct reflections peaking at 25.1° and 48.0°, respectively, appear in the diffractogram of the sample annealed at 500°C. These peaks were compared with the reflections expected for the three polymorphs of TiO₂: anatase, rutile, and brookite. The tetragonal anatase phase exhibits its three most intense signals at 2θ angles of 25.2° (major), 37.7°, and 47.9° (JCPDF No. 21-1272). The tetragonal rutile phase is characterized by the three most intense reflections at 27.4° (major), 35.9°, and 54.3° (JCPDF No. 34-0180), and the orthorhombic brookite phase typically shows three reflections with nearly similar intensities at 25.4°, 25.7°, and 30.8° (JCPDF No. 29-1360). Thus, the GIXRD pattern of the TiO₂ nanolayer can be best explained by its assignment to the anatase phase, though only the two most intense peaks corresponding to the (101) and (211) crystal planes can be resolved. In the 600°C sample two peaks at 24.8°C and 48.3°C are observed, slightly shifted with respect to the reflections of the 500°C sample. Again, this diffractogram can be explained best by assigning it to the anatase structure. However, the shift of the (101) reflex from the expected 25.2° to 24.8° suggests a strain of the elementary cell in the c-direction. Klaysri et al. reported on a small shift of XRD signals in nanocrystalline anatase upon high temperature treatment in N₂ atmospheres, which was explained by the incorporation of N atoms into the TiO₂ crystal structure accompanied by a distortion of the TiO₆ octahedron. However, the authors reported on a shift to higher 2θ angles, whereas we observed a shift to lower angles. Rajender and Giri described a broadening and a slight shift of the (101) reflex of anatase to lower angles in the X-ray diffractogram of ball-milled TiO₂ nanocrystals and assigned this to milling-induced tensile strain in the nanocrystals. This shift was accompanied by the appearance of two additional peaks at 31.3° and 41.6°, which were attributed to the (112) and (312) planes of a newly formed oxygen-deficient Ti₃O₅ phase (JCPDS No. 74-0819). A closer look at the diffractogram of the TiO₂ nanolayer annealed at 600°C of our work reveals a weak reflex at 31.5°. It remains speculative if a strained anatase accompanied by the formation of a Ti₃O₅ phase can also be the explanation for the observed XRD pattern of the 600°C TiO₂ nanolayer investigated in our work, since the expected second peak in the range of 41°-42° could not be identified. However, it seems reasonable that a high annealing temperature cannot only induce a phase change from amorphous TiO₂ to crystalline anatase, but that it can also introduce tensile stress and the formation of oxygen-deficient phases in TiO₂ nanolayers coated on quartz glass substrates.

**SEM analysis**

In order to elucidate the morphology and film thickness of the TiO₂ nanolayers, cross-sections of the samples annealed at 200, 300, 500, and 600°C were prepared and investigated by FESEM. In addition, EDX elemental maps were recorded to identify the elemental distribution in the cross-sections. Figure S1 shows the scanning electron micrograph of the TiO₂ coated FTO glass calcined at 200°C and the corresponding EDX elemental maps for Si, Sn, and Ti with a magnification of 50.000. The Si map clearly indicates the quartz glass and the Sn map the dimension of the FTO layer. Only a very weak contrast in the Ti map above the FTO layer hints at the TiO₂ nanolayer. In the SEM images recorded with the higher magnification of 80.000 the glass substrate, the FTO sublayer, and the TiO₂ coating can be unambiguously distinguished (Figure 3).

![Figure 3](image-url)  
*Figure 3.* Cross-sectional FESEM images of TiO₂ coated FTO glass slides calcined at temperatures indicated in the images recorded with 40.0 k magnification (a-d) and corresponding images with 80.0 k magnification (e-h).

It becomes also obvious that the morphology of the FTO layer is rather rough. However, the substrate is completely
covered by a continuous TiO\textsubscript{2} film. The TiO\textsubscript{2} layer exhibits a thickness of about 100-150 nm for the sample annealed at 200°C, and of about 50-100 nm for the 300°C film. Upon annealing at 500°C the TiO\textsubscript{2} layer adjusts to the roughness of the underlying FTO substrate and the thickness decreases to about 50 nm. As for the 600°C sample the TiO\textsubscript{2} film can be hardly distinguished from the FTO sublayer shrinking to thicknesses of approximately 50 nm or less. This shrinking of the film and the increased roughening can be explained by the progressing crystallization process with higher temperatures and would also be in agreement with the temperature-induced strain on the 600°C TiO\textsubscript{2} nanocrystal lattice as postulated for the interpretation of the GIXRD results.

**Photocatalytic activity**

![Figure 4](image.png)

**Figure 4.** a) Methylene blue degradation kinetics expressed as ratio between actual (c) and starting concentration (c\textsubscript{0}) versus time on neat and TiO\textsubscript{2}-coated FTO glass slides with and without 369 nm irradiation. Data points indicate the mean of three measurements and error bars denote the standard error of the mean. b) Bacterial degradation kinetics expressed as logarithm of survival rates versus time on neat and TiO\textsubscript{2}-coated FTO glass slides with and without UV-A irradiation. The data point of the TiO\textsubscript{2} 500°C with UV sample at 90 minutes cannot be shown in the logarithmic presentation since the survival rate approached zero. The drawn lines serve as guide to the eyes.

The photocatalytic activity of the TiO\textsubscript{2} nanolayers was investigated by measuring the degradation rate of MB dye under 369 nm light irradiation at 1000 W/m\textsuperscript{2} and in the dark. The MB degradation curves for all measured samples are summarized in Figure 4a. The uncoated FTO glass showed after 20 minutes a small but distinct reduction of the initial MB concentration by 5%. All TiO\textsubscript{2}-coated samples exhibited a significantly larger MB degradation. The strongest effect was observed for the TiO\textsubscript{2} nanolayer annealed at 500°C, closely followed by the 400°C and 600°C samples, with a reduction of the initial MB concentration after 20 minutes between 26 and 29%. The samples annealed at the lower temperatures of 300 and 200°C, respectively, followed with a considerably lower MB degradation of about 19 and 14%, respectively. The MB degradation was also investigated in the dark. As a result, no sample achieved a reduction of the initial MB concentration by more than 6% on average after 20 minutes. Hence, the MB degradation can be clearly associated with a photocatalytic effect of TiO\textsubscript{2}. The MB degradation rate \( R_{MB} \) was calculated for all samples by the following equation:

\[
R_{MB} = \frac{c_0 - c_{final}}{t_{time}}
\]

with \( c_0 \) being the initial MB concentration and \( c_{final} \) the MB concentration after 20 minutes. The resulting degradation rates are summarized in Table S1 and reflect the same trend as already discussed before, i.e. with the highest rates observed for the 500, 400°C, and 600°C samples, followed by the TiO\textsubscript{2} layers annealed at 300 and 200°C, respectively. The smallest value was calculated for the uncoated glass.

**Antimicrobial activity**

The antimicrobial activity of uncoated and TiO\textsubscript{2}-coated FTO glasses annealed at 300 and 500°C under UV-A irradiation was tested by measuring the photocatalytic degradation of E. coli bacteria. In preliminary tests a dilution step of 1:1000 for the E. coli
overnight culture proved to be ideal to obtain a high but still countable number of cultures. This number was defined as \( S_0 \) value. All bacteria-treated glass slides exhibited a degradation of the number of bacteria cultures after irradiation and plate pouring. Images of petri dishes with bacterial cultures treated under different experimental conditions are shown in Figure S2 and the kinetic analyses of the degradation is summarized in Figure 4b.

As a result, a distinct photocatalytic antibacterial effect of the TiO\(_2\) coatings could be observed. The TiO\(_2\) film treated at 300°C could reduce the survival rate to about 6.7% after 60 minutes UV-A irradiation. The 500°C sample exhibited even a survival rate of only 1.7% after the same period of time. However, it becomes obvious that even the blind samples measured in the dark after 120 min indicated a significant bacterial degradation to a maximum survival rate of about 36%. Obviously, the experiments with living material such as bacteria suffer from a challenging reproducibility making it difficult to deduce quantitative numbers and to compare samples with only slightly different properties. However, the superior photocatalytic effect of the TiO\(_2\) thin film on FTO calcined at 500°C on the degradation of E. coli relative to the uncoated and 300°C TiO\(_2\) sample can be unambiguously identified supporting the trends already observed for the MB degradation kinetics.

**Electrochemical characterization**

**Linear sweep voltammetry (LSV)**

LSV measurements were performed for uncoated and TiO\(_2\)-coated FTO glasses to measure the photopotentiodynamic characteristics of the samples and to determine open-circuit potentials (OCP). Without irradiation no positive currents were recorded within the electrochemical potential range between -1.0 and 0.5 V versus Ag/AgCl for all investigated samples. The results under 369 nm irradiation at a light intensity of 100 W/m\(^2\) are summarized in Figure 5a. The uncoated sample shows nearly no photocurrent in the investigated potential range. Only above the break-down potential of about 0.5 V versus Ag/AgCl a positive current is measured. The TiO\(_2\)-coated FTO glass annealed at 200°C exhibits a very small photocurrent with an OCP of -0.249 V versus Ag/AgCl. Significant photocurrents are measured for the 300, 400, 500 and 600°C annealed TiO\(_2\) samples. The OCP is shifted to more negative values with increasing annealing temperature, i.e. to -0.672 V (300°C), -0.715 V (400°C), and -0.759 V (500°C), respectively. Only annealing at 600°C induces with an OCP of -0.728 V a small shift to a slightly more positive value with respect to the 500°C sample. The direct comparison of the potential-dependent photocurrent characteristics exhibits remarkable differences. At high potentials above 0 V versus Ag/AgCl the photocurrents of the coated samples rank in the following order: 400°C TiO\(_2\) > 600°C TiO\(_2\) > 500°C TiO\(_2\) > 300°C TiO\(_2\) > 200°C TiO\(_2\).

**Figure 5.** a) Linear sweep voltammetric curves of neat and TiO\(_2\)-coated FTO glass slides recorded under 369 nm irradiation at 100 W/m\(^2\) and b) corresponding incident photon conversion efficiencies (IPCE) of the samples calculated for the potentials of 0.5 V and -0.631 V versus Ag/AgCl, respectively. The asterisk denotes that the data point at “0” corresponds to the uncoated sample. The drawn lines in b serve as guide to the eyes.

Moreover, the fill factor, defined as ratio between the area enclosed by the actual photocurrent and voltage in the voltammogram to the area of an ideal rectangle (where the photocurrent rises instantaneously to the maximum value at the OCP), is largest for the 500°C sample followed by the 400°C and 600°C sample, respectively. The smaller the fill factor, the larger the influence of increased charge recombination as well as hindered charge transport and charge separation on the resulting photocurrent. This is also reflected by the order of the incident photon conversion efficiencies (IPCE) at 0.5 V versus Ag/AgCl.
Klahr et al. explained this photocurrent slope by a very short hole drift length, which could be also understood in terms of a charging of surface states characterized by a spike after turning the light on followed by a slow decay.

After turning the light on, photogenerated holes in titania diffuse to the surface of the layer, inducing a corresponding rather high photocurrent in the semiconductor-liquid junction predicting a linear dependence between photocurrent and light intensity. However, the observed photocurrent transients depicted in Figure 5(b) were calculated by the following equation:

$$\text{IPCE} = \frac{j_{\text{photo}} \cdot h \cdot c}{I_{\text{light}} \cdot e \cdot \lambda},$$

where $j_{\text{photo}}$ is the photocurrent density, $h$ the Planck constant, $c$ the speed of light, $I_{\text{light}}$ the light intensity, $e$ the elementary charge, and $\lambda$ the irradiation wavelength. The 400°C TiO$_2$ sample shows at 0.5 V versus Ag/AgCl with 8.6% the highest IPCE, followed by the 600°C and 500°C sample with 4.3, and 3.7%, respectively. However, at potentials closer to the OCP this order changes. E.g., at -0.631 V the 500°C TiO$_2$ sample exhibits now the highest IPCE with 1.8%, followed by 400°C TiO$_2$ with 1.4%. At this potential the 600°C TiO$_2$ film shows only an IPCE of 0.5%.

The photocurrent $j_{\text{photo}}$ is expected to show a monotonic behavior over the whole investigated potential range, if the bias potential does apply completely across the whole space charge layer. According to the Gärtner-Butler model$^{31,32}$ $j_{\text{photo}}$ should depend on the electrochemical potential with $E^{1/2}$ after:

$$I_{\text{photo}} = eI_0\alpha w = eI_0\sqrt{\frac{2\varepsilon\varepsilon_0(E - E_{\text{fb}})}{qN_d}},$$

with $e$ being the elementary charge, $I_0$ the incident light power, $\alpha$ the light absorption coefficient, $w$ the width of the space charge layer, $\varepsilon$ the relative dielectric constant of TiO$_2$, $\varepsilon_0$ the vacuum permittivity, $q$ is the charge transferred per ion, $N_d$ the doping density, and $E_{\text{fb}}$ the flat band potential. However, the Gärtner-Butler model does not involve charge recombination in the depletion layer or pinning of the Fermi level by surface state charging. In the latter case the bias potential does not apply across the space charge layer, but across the Helmholtz layer, which is often corroborated by a plateau in the $E$ versus $j_{\text{photo}}$ curves. There is no obvious plateau observable in the LSV curves of the investigated TiO$_2$ samples, but especially the peculiar behavior of the 400°C TiO$_2$ nanolayer could be also understood in terms of a charging of surface states characterized by a rather broad energy distribution. E.g., at potentials more positive than the OCP the slope of the $j_{\text{photo}}$ versus $(E - E_{\text{fb}})^{1/2}$ curve changes strikingly at about -0.6 V, -0.5 V, and -0.2 V versus Ag/AgCl. The 600°C sample with its strongly sloped photocurrent might also be at least partially explained by Fermi level pinning caused by surface states with a rather broad distribution at lower energies. Interestingly, a similar nearly linear dependence of the photocurrent on potential was observed for thin film hematite photoelectrodes.$^{33}$ Klahr et al. explained this photocurrent slope by a very short hole drift length, which could be also an explanation for the behavior of the strained 600°C TiO$_2$ sample.

**Chopped light chronoamperometry (CLCA)**

The recombination at surface states can be investigated more closely by chronoamperometric measurements under chopped light conditions. The resulting photocurrent transients are reported in Figure 6 under 100 W/m$^2$ (a) and 1000 W/m$^2$ (b) irradiation at 369 nm and at an applied potential of 0.1 V versus Ag/AgCl.

The absolute photocurrent intensities measured under irradiation reflect the results of the photopotentiodynamic measurements at higher potentials, i.e. the highest photocurrent is observed for the 400°C TiO$_2$ nanolayer, followed by the 600, 500, 300, 200°C TiO$_2$, and finally by the uncoated sample. Furthermore, the steady-state photocurrent measured just before the light was turned off was plotted versus the incident light intensity for all TiO$_2$ samples, resulting in a nearly ideal linear relationship (Figure S3). These results are in agreement with the aforementioned Gärtner-Butler model for an illuminated semiconductor-liquid junction predicting a linear dependence between photocurrent and light intensity. However, the observed photocurrent transients depicted in Figure 6 are all characterized by a spike after turning the light on followed by a slow decay of the photocurrent. This behavior has been assigned to a surface recombination mechanism.$^{20}$ After turning the light on, the photogenerated holes in titania diffuse to the surface of the layer, inducing a corresponding rather high photocurrent in the external circuit during the first seconds. Then, these holes get increasingly trapped by surface states. The thus initiated buildup of trapped holes acts as efficient recombination site for photogenerated electrons leading to a decrease of the initial photocurrent until a steady-state value is reached after a certain time. Corresponding time constants can be deduced from the photocurrent transients by applying the following two-phase exponential decay function:

$$j_{\text{photo}} = j_0 + A_1 \cdot \exp\left[-\frac{(t - t_0)}{\tau_1}\right] + A_2 \cdot \exp\left[-\frac{(t - t_0)}{\tau_2}\right],$$

where $j_0$ is the steady-state photocurrent density, $j_{\text{photo}}$ is the photocurrent density at time $t$, $t_0$ is the time when the light is turned on, $A_1$ and $A_2$ are constants, and $\tau_1$ and $\tau_2$ are the time constants for the slow and the fast decay component, respectively. The obtained time constants for samples annealed at 300-600°C are summarized in Table S2. The photocurrent of the 200°C sample was too small to obtain a reasonable fit. All other transients can be fitted by a faster component with time constants...
between 0.12 and 0.69 s, and a slower component with values between 2.37 and 9.04 s. An exception is the 300 °C TiO$_2$ sample under 1000 W/m$^2$ irradiation with a time constant $\tau_2$ of 25.9 s. However, this component accounts for only 15.9% of the decay ($A_2/(A_1 + A_2)$) and the decay of the latter sample could be also described with a reasonably good correlation by a one-phase exponential decay function. In contrast, the slow decay is the dominating component for the 400 °C (70.0%), 500 °C (52.7%), and 600 °C (64.6%) sample under 100 W/m$^2$ irradiation. Under the higher irradiation intensity of 1000 W/m$^2$ $\tau_2$ decreases and its relative portion to the overall decay is diminished for the 400 °C (30.6%), 500 °C (41.2%), and 600 °C (38.8%) sample. Consequently, the surface recombination is accelerated with higher irradiation intensity. The highest decay time constants at 100 W/m$^2$ are observed for the 400 °C and 600 °C sample. The high influence of surface states on the photocurrent would be in agreement with the postulated Fermi level pinning by surface states discussed to explain the LSV measurements accompanied by the observation of rather low fill factors, which was especially apparent for the 400 and 600 °C TiO$_2$ samples, too.

**Intensity-modulated photocurrent (IMPS) and photovoltage spectroscopy (IMVS)**

IMPS and IMVS are powerful techniques to extract photoelectrochemical kinetic constants for majority and minority charge carriers in semiconductors by applying a small sinusoidal perturbation to the incident light intensity.

In IMPS the photocurrent-time response is measured under closed-circuit conditions at a defined DC bias potential. At a bias potential more positive than the OCP the photogenerated majority carrier electrons diffuse to the current collecting back-contact of the TiO$_2$ film. The average electron transit time ($\tau_D$) to the back-contact (or electron mobility) is given by the phase relationship between photocurrent perturbation and light modulation. It can be directly calculated from the complex Nyquist representation of the IMPS response:

$$\tau_D = \frac{1}{\omega_{\text{min,IMPS}}}.$$  

with $\omega_{\text{min,IMPS}}$ being the angular frequency of the minimum of the IMPS Nyquist semicircle. Moreover, absorbed photons generate a flux of minority carrier holes $J_{\text{gen}}$ in the valence band toward the semiconductor-electrolyte interface. A part of the photogenerated holes diffuses with the flux $J_{\text{ct}}$ to the semiconductor surface realizing an oxidation reaction via interfacial charge transfer. The quantum efficiency $\eta_{\text{ct}}$ of the surface hole charge transfer process is defined as the quotient between hole charge transfer rate constant $k_{\text{ct}}$ and the sum of $k_{\text{ct}}$ and hole surface recombination constant $k_{\text{rec}}$. $\eta_{\text{ct}}$ can be deduced from the IMPS Nyquist plot by calculating the ratio between the low-frequency intercept (LFI) and high-frequency intercept (HFI) of the IMPS semicircle with the real axis:

$$\eta_{\text{ct}} = \frac{J_{\text{ct}}}{J_{\text{gen}}} = \frac{k_{\text{ct}}}{k_{\text{ct}} + k_{\text{rec}}} = \frac{\text{LFI}}{\text{HFI}}.$$  

$\eta_{\text{ct}}$ is diminished by the competing flux $J_{\text{rec}}$ of holes directly recombining with electrons from the conduction band at the semiconductor surface according to the following conversation equation:

$$J_{\text{gen}} = J_{\text{ct}} + J_{\text{rec}}.$$  

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**Figure 6.** Chopped light chronoamperometric measurements at an applied potential of 0.1 V versus Ag/AgCl of neat and TiO$_2$-coated FTO glass slides calcined at temperatures indicated in the legend under a) 100 W/m$^2$ and b) 1000 W/m$^2$ irradiation at 369 nm.
The time constant $\tau_n$ of this combined charge transfer and recombination process is the inverse of the sum of $k_{ct}$ and $k_{rec}$, and can be directly deduced from the angular frequency $\omega_{\max,\text{IMVS}}$ of the maximum of the IMPS Nyquist semicircle:

$$\omega_{\max,\text{IMVS}} = (\tau_n)^{-1} = k_{ct} + k_{rec}. \quad (8)$$

Bulk majority carrier transport properties can be investigated with IMVS by measuring the photovoltage perturbation upon light modulation under open-circuit conditions. Here, the electron life time $\tau_n$ is derived from the angular frequency of the minimum of the IMPS Nyquist semicircle $\omega_{\min,\text{IMVS}}$:

$$\tau_n = 1/\omega_{\min,\text{IMVS}}. \quad (9)$$

In panels a and b of Figure S4 IMPS diagrams plotted in the complex plane (Nyquist representation) for the different TiO$_2$ films on FTO are exemplarily depicted for a DC bias potential close to the OCP (-0.6 V) and for a positive voltage (+0.2 V), respectively. The high-frequency part of all circles is in the forth quadrant of the diagram (i.e. positive real and negative imaginary numbers) and $\omega_{\min,\text{IMVS}}$ at the minimum of the IMPS Nyquist semicircle can be easily deduced to calculate the average majority carrier electron transit time ($\tau_D$) (Figure 7d). In addition, all IMPS measurements are characterized by a low-frequency part lying in the first quadrant of the diagram (i.e. positive real and positive imaginary numbers). From this part the rate constants for the minority hole charge transfer and recombination can be deduced as described before. The respective rate constants are plotted in panel a of Figure 7 for all applied bias potentials. All received recombination rates $k_{rec}$ decrease with increasing potential except for the 200°C sample, pointing for the other samples to a less dominant electron-hole recombination at potentials much more positive than the OCP. It becomes also obvious, that the recombination is with values below 0.1 s$^{-1}$ at 0.2 V versus Ag/AgCl slowest for the 400°C sample, followed by the 500 and 600°C TiO$_2$. The ranking switches at potentials below 0 V, where the 500°C TiO$_2$ film now exhibits the smallest recombination rate, followed by the 600 and 400°C sample, respectively. In contrast, the recombination is fastest for the 200°C, and second fastest for the 300°C sample, reaching values that are nearly two or even three orders of magnitudes larger than the rates of the high temperature samples. A similar trend is observed for the charge transfer constant $k_{ct}$. Here, the charge transfer is fastest for the samples annealed at the two lowest temperatures with values of 20-40 s$^{-1}$ at potentials more positive than -0.6 V. The 400, 500, and 600°C samples can be hardly distinguished at potentials above -0.6 V exhibiting very similar values being approximately one order of magnitude smaller than the rates of the low temperature samples. With equation 6 the quantum efficiencies of the hole charge transfer process were calculated for each sample and the results are summarized in Figure 7b. As could be already expected from the rate constants, the TiO$_2$ film annealed at 200°C shows over the whole investigated potential range by far the lowest charge transfer efficiency with values of only about 20%. The 300°C TiO$_2$ shows better but still significantly worse quantum efficiencies than the rest of the samples, not achieving values exceeding 99%. The samples annealed at temperatures of 400, 500 and 600°C exhibit the highest quantum efficiencies, reaching nearly 99% at 0.2 V. However, the TiO$_2$-coated FTO glass annealed at 400°C catches up with the quantum efficiency of the other high temperature samples only at a potential of at least -0.2 V, while it is significantly smaller at more negative potentials. This can be explained by the higher recombination rate and reflects also the potential dependent trends discussed for the LSV measurements.

Panels c and d of Figure S4 show exemplarily the results of the IMVS measurements at light intensities of 100 and 1000 W/m$^2$, respectively. At the lower light intensity all samples give a clear semicircle in the complex Nyquist plane with nearly all values lying in the forth quadrant of the diagram. The angular frequency $\omega_{\min,\text{IMVS}}$ at the minimum can be easily identified to calculate the electron lifetime $\tau_n$. However, the IMVS plots of the 500 and 600°C TiO$_2$ films at the higher light intensity are characterized by two not clearly separated semicircles, pointing to more than one charge recombination process. In these cases $\omega_{\min,\text{IMVS}}$ was still determined at the global minimum of the complex diagram to obtain the time constant for the (dominant) slower process at smaller frequencies. It is also remarkable that the IMVS diagrams of the 400, 500 and 600°C samples show also values in the first quadrant of the complex plane. The determined electron lifetimes are plotted in Figure 7c versus the incident photon flux. By applying a least-square linear regression for the approximately linear three or four data points of each sample, the slopes of the log-log electron lifetime-photon flux dependencies were deduced. Only the 200°C shows a slightly positive slope, but due to the low data quality of the IMVS diagrams for this sample the interpretation is omitted. The 300 and 400°C samples exhibit a slope of around -0.8. This value is close to -1, indicating that the reactions driven by electrons trapped in surface states are approximately first order in light intensity. In contrast, the slopes of the 500°C and even more pronounced for the 600°C sample are significantly smaller. Hence, these values indicate second order (theoretical slope: -0.5) or even higher order processes in light intensity. Finally, panel d of Figure 7 shows the electron transit times in dependence of the DC bias potential as deduced from the IMPS diagrams. All electron transit times decrease with increasing potential at potentials above the OCP. Again, the values for the TiO$_2$ film annealed at 200°C exhibit the largest deviations from the other samples with the lowest electron transit time at potentials more positive than the OCP. All other transit times are at least twice as high, at which the 300 and 400°C samples generally show the highest electron transit times and thus smallest
Figure 7. a-b) Kinetic parameters as deduced from IMPS measurements with $k_{\text{rec}}$ being the surface hole recombination rate (a, filled symbols), $k_{\text{ct}}$ the surface hole charge transfer rate (a, open symbols), and $\eta_{\text{ct}}$ the hole charge transfer efficiency (b) at different potentials. c) Log-log plot of electron lifetime $\tau_e$ versus incident photon flux $\Phi_{\text{photon}}$ as retrieved from IMVS measurements. Solid lines represent linear least-square regressions of each data set with the obtained slopes given in the legend. d) Electron transit times $\tau_D$ for each TiO$_2$-coated FTO retrieved from IMPS measurements at different applied potentials and under 369 nm 100 W/m$^2$ irradiation. The drawn lines in a, b, and d serve as guide to the eyes.

electron mobilities. Obviously, electron transit times are for all samples at least two orders of magnitude smaller than the electron lifetimes, indicating rather higher quantum efficiencies for the electron charge transfer process. In general, electron lifetimes and transit times are significantly smaller than the reciprocal hole charge transfer and recombination rates. This points to rate-determining hole charge transfer dynamics in all investigated TiO$_2$ samples.

Photoelectrochemical Impedance Spectroscopy (PEIS)

PEIS is another powerful method to study and understand the charge transfer in irradiated semiconductors in contact with an electrolyte. Klahr et al. suggested various physical models for the charge carrier dynamics in hematite photoelectrodes for water oxidation including the effects of surface states on the Fermi level and charge redistribution. A typical equivalent circuit used to explain charge carrier dynamics in irradiated semiconductor-electrolyte junctions is depicted in Figure 1c, with $R_s$ being the TiO$_2$/FTO (back-contact) resistance, $R_{\text{ct,bulk}}$ the resistance for direct interfacial hole charge transfer via the valence band, $R_{\text{trap}}$ the resistance for trapping of holes from the valence and electrons from the conduction band at surface states, $R_{\text{ct,trap}}$ the resistance for charge transfer of holes via surface states, $C_{\text{bulk}}$ is the capacitance associated with the space charge layer in series with the Helmholtz layer, and $C_{\text{trap}}$ is the surface state capacitance. In this model $R_{\text{ct,bulk}}$ can be associated with the rate constant $k_1$ and $R_{\text{trap}}$ with the rate constants $k_2$ and $k_4$. In addition, the charge transfer via surface states resistance $R_{\text{ct,trap}}$ can
be associated with \( k_3 \), though a discrimination between \( R_{ct,\text{trap}} \) and \( R_{ct,\text{bulk}} \) just based on equivalent circuit fitting is often very challenging.

In Figure S5 PEIS Nyquist plots for the TiO\(_2\) nanolayers annealed at 300, 400, 500, and 600°C, respectively, and measured under 100 W/m\(^2\) irradiation at potentials between -800 and +200 mV versus Ag/AgCl are shown. PEIS results were analyzed by fitting the data with the equivalent circuit depicted in Figure 1. The \( C_{\text{bulk}} \) element was fitted by using a constant phase element (CPE) and the corresponding capacitances were calculated according to the equation derived by Brug et al.\(^{36}\). The thus extracted circuit element parameters were plotted versus the applied potentials and are presented in Figure 8. The 200°C sample is not further discussed since the obtained spectra were characterized by a low signal to noise ratio that could not be fitted very will with the discussed equivalent circuit. The \( R_s \) data are not shown since the obtained values were rather constant over the whole investigated potential range for all samples with magnitudes between about 7 and 13 Ω, which is also consistent with an ohmic behavior of the FTO/TiO\(_2\) interface.

**Figure 8.** a-d) Equivalent circuit element parameters extracted by fitting the PEIS data of TiO\(_2\) nanolayers from Figure S5 with the equivalent circuit shown in Figure 1c in dependence on the applied potential. The drawn lines serve as guide to the eyes.

In order to test the plausibility of the applied physical model the obtained resistances \( R_{ct,\text{bulk}} \) and \( R_{ct,\text{trap}} \) associated with direct charge transfer via the valence band and charge transfer via surface states, respectively, were compared with the resistance \( R_{\text{LSV}} \) obtained by the derivation of the linear sweep voltammetry curves from Figure 5 according to:

\[
R_{\text{LSV}} = \left( \frac{dI_{\text{photo}}}{dE} \right)^{-1}.
\]
The summarized data in Figure 9 show that all resistances follow similar trends with increasing potential for each sample. However, the resistances extracted from the PEIS data are systematically smaller than the resistances obtained by the derivation of the photocurrents. An exception is the 400°C sample. Here, the $R_{\text{ct, bulk}}$ values follow very well the derived photocurrents. We also calculated a total resistance $R_{\text{tot}}$ by the addition of all serial resistances and parallel reciprocal resistances, respectively, as follows from the interconnection of the respective circuit elements in the applied equivalent circuit. Again, $R_{\text{tot}}$ is systematically smaller than the derivative of the photocurrent. It should be also noted, that $R_{\text{ct, trap}}$ and $R_{\text{ct, bulk}}$ cannot be distinguished in the 500°C and 600°C sample, respectively. A fit of similar quality was also possible by completely omitting, e.g., the $R_{\text{ct, trap}}$ element in the circuit resulting in a fit with a halved value for $R_{\text{ct, bulk}}$ that also equals the $R_{\text{tot}}$ value of the complete circuit (as expected for parallel resistances). Cachet and Sutter explained differences between the AC response and the DC photocurrent of TiO$_2$ by the contribution of very slow processes to the AC signal in the PEIS measurements at very low modulation frequencies. This interpretation would be in agreement with the slow temporal decay of the photocurrents as observed in the CLCA measurements (cf. Figure 6). If the physical model and former attribution of the resistances to the respective charge transfer processes is correct, the (faster) direct charge transfer of holes via the valence band would perfectly explain the photocurrent of the 400°C sample. In contrast, the photocurrent of the 300°C TiO$_2$ is in intensity and potential dependence closer to the surface state charge transfer associated with $R_{\text{ct, trap}}$.

Figure 9. Comparison of resistances obtained by the derivation of linear sweep voltammetry curves after potential $E$ with resistances deduced from Nyquist PEIS plots for TiO$_2$ nanolayers annealed at a) 300°C, b) 400°C, c) 500°C, and d) 600°C.

In addition, the magnitudes of the resistances deduced from the PEIS measurements can at least qualitatively explain the trends observed for the photocurrent curves of the different TiO$_2$ samples. The 300°C sample exhibits the highest $R_{\text{LSV}}$, $R_{\text{ct, bulk}}$, $R_{\text{ct, trap}}$ and $R_{\text{tot}}$ values. Since these values are associated with the efficiency of the charge transport from the semiconductor to
the solution, this in agreement with the lower $\eta_{ct}$ value for this sample in comparison to the TiO$_2$ nanolayers annealed at higher temperatures and as extracted from the IMPS measurements (cf. Figure 7b). Moreover, the measured absolute photocurrent increases at positive potentials versus Ag/AgCl in the direction 300°C, 500°C, 600°C and 400°C, and this behavior is also well reflected by the deduced charge transfer resistances decreasing in the same direction. Since $R_{ct,bulk}$ and $R_{ct,trap}$ are associated with the rate constants $k_1$ and $k_3$, respectively, it is expected that these constants also increase in the direction 300°C, 500°C, 600°C, and 400°C.

As for the extracted capacitances, there is a significant difference between $C_{bulk}$ of the 300°C and 400°C samples on the one hand and the 500 and 600°C samples on the other hand. Since these quantities are associated with the capacitance of the space charge layer in series with the Helmholtz capacitance, this points to a very high charge accumulation and a slow diffusion and separation of charges in the space charge layer for the two samples annealed at lower temperatures. This would be in agreement with the relatively large electron transit time of these samples as deduced by the IMVS measurements (cf. Figure 7d). Moreover, the $C_{trap}$ values of the 400°C sample above -0.8 V versus Ag/AgCl - and this also holds true at more positive potentials for the 300°C sample - are systematically smaller than the respective values of the 500°C and 600°C samples. Since this capacitance is associated with the hole transfer ability to the electrolyte, this suggests that the 400°C TiO$_2$ nanolayer (as well as the 300°C sample at higher potentials) exhibits the lowest accumulation of holes at the semiconductor-electrolyte interface. This could be explained by effective surface hole transfer to the electrolyte in the case of the 400°C sample and an efficient hole electron recombination at surface states in the case of the 300°C sample. However, the $R_{trap}$ resistances for the 300 and 400°C samples do not agree very well. The quantities of the latter TiO$_2$ nanolayer are systematically higher over the whole investigated potential range, followed by the resistances of the 600°C, 500 and 300°C samples. This parameter indicates a hampered trapping of holes from the valence and electrons from the conduction band at surface states and points to lower corresponding rate constants $k_2$ and $k_4$ for the 400°C sample, while this rate is highest for TiO$_2$ annealed at only 300°C. This interpretation would be in agreement with the observed order of the decay time constants in Table S2 deduced from the CLCA transients, which were also correlated with the respective hole recombination rate constants at surface states.

We also investigated the electrochemical impedance of all samples without irradiation to elucidate the influence of light on charge transfer. As a result, $R_{tot}$ values extracted by fitting the experimental curves with the same equivalent circuit as the PEIS data are at least two orders of magnitude larger than the corresponding quantities under irradiation (e.g. 4.01 kΩ with 100 W/m$^2$ versus 249 kΩ without irradiation for the 500°C sample at -0.2 V versus Ag/AgCl) pointing to a strongly hampered semiconductor-electrolyte charge transfer of the (intrinsic and extrinsic charge carriers) in the dark. This could be expected since only the irradiation induced photovoltage provides a sufficient thermodynamic driving force for interfacial charge transfer. However, the $C_{trap}$ values do not differ much in the presence or absence of light (e.g. for 500°C sample at -0.2 V: 22.1 µF with 100 W/m$^2$ versus 21.4 µF without irradiation) suggesting that irradiation does not significantly influence the charge accumulation at surface states. Moreover, the deduced $R_{trap}$ values were slightly larger in the absence of light (e.g. for 500°C sample at -0.2 V: 3.47 Ω with 100 W/m$^2$ versus 4.26 Ω without irradiation), but the $C_{bulk}$ parameters were very similar (e.g. for 500°C sample at -0.2 V: 983 nF with 100 W/m$^2$ versus 999 nF without irradiation). This points to an accelerated trapping of charge carriers in surface states, but to nearly no increase of charge carriers in the space charge layer upon irradiation.

**Discussion**

Since the structural analysis has shown, that only the TiO$_2$ samples annealed at temperatures of at least 500°C are clearly crystalline, it becomes obvious that the presence of crystalline anatase is not necessarily a prerequisite for both a high photocatalytic and photoelectrocatalytic activity. Instead, the 400°C sample showing no distinct reflections in the diffractogram exhibits similarly high photocurrents and MB degradation rates as the clearly crystalline anatase samples annealed at 500 and 600°C, respectively.

However, electron-hole recombination constants as deduced by IMPS can serve as discriminator between samples with high and low photoactivities. Hence the 200 and 300°C TiO$_2$ films are characterized by a exceedingly fast electron-hole recombination. In addition, the resulting hole charge transfer efficiencies are significantly lower than in other samples, since the very effective recombination processes cannot be balanced by the rather high charge transfer rates. The low IPCE, photocurrents, MB degradation rates and antibacterial activity of the low temperature samples can hence be explained by the dominating recombination of photogenerated holes with electrons. This interpretation is further supported by the highest semiconductor-electrolyte charge transfer resistance of all samples as extracted from the AC response upon irradiation. Due to the amorphous nature of the TiO$_2$, a very high density of defect states can be expected acting as very effective sites for charge carrier recombination, while the absence of conduction and valence bands with long-range order hampers an effective charge transfer from the bulk to the electrolyte.

The samples annealed at 400, 500, and 600°C show very similar MB degradation rates, but a very different photopotentiodynamic behavior. The former sample is characterized by the highest IPCE at very positive potentials. However, at potentials close to the OCP the photocurrent and IPCE are similar or even smaller than observed for the 500°C sample. This potential
dependent effect can be explained by the respective potential dependent hole charge transfer dynamics of the different samples. The surface hole recombination rate $k_{ncc}$ is higher and the resulting hole charge transfer efficiency $\eta_{ct}$ is smaller for the 400°C than for the 500 and 600°C samples at potentials closer to the OCP. Only at potentials above -0.2 V versus Ag/AgCl the 400°C sample can catch up with the respective values of the 500 and 600°C TiO$_2$ layers or does even outperform them. In this potential range the photocurrent and ICPE order of the samples switches as well. Hence the lower photoactivity of the 400°C TiO$_2$ at more negative potentials can be explained by a rather strong charge recombination of surface holes. This interpretation is supported by the rather small fill factor, low electron lifetime $\tau_e$ and exceptionally high electron transit time $\tau_D$ at negative potentials. This would be in agreement with the absence of crystalline features in the diffractogram pointing to a still high density of defect states in the 400°C nanolayer. Small (semi)crystalline, defect-rich domains might have already formed at this intermediate temperature (though not observable in the diffractogram due to extreme peak broadening) giving rise to the much higher photoactivity as compared to the 200 and 300°C sample. Moreover, the very dominant but slow photocurrent decay in the CLCA transient experiments - which was interpreted in terms of a recombination of photogenerated holes with surface states - further supports the presence of a highly reactive surface. In addition, the OCP is slightly more positive than the respective values of the 500 and 600°C samples, pointing to a lower thermodynamic driving force to participate in redox reactions. In contrast, the highest observed photocurrent at very positive potentials would be in agreement with the lowest charge transfer resistance of all samples. Hence a very high charge transfer rate $k_1$ for direct hole transfer via the valence band to the electrolyte can be expected for this sample.

The 600°C sample is characterized by a slightly reduced MB degradation rate, a shift of the OCP to more positive values and a lower photocurrent at negative potentials versus Ag/AgCl as compared to the respective values of the 500°C sample. At negative potentials $k_{ncc}$ is slightly higher than the respective rate constant of the sample annealed at 500°C. This observation could give rise to a similar explanation in terms of an increased surface hole recombination rate as already discussed for the 400°C TiO$_2$. The charge transfer resistance at positive potentials is smaller than the value of the 500°C TiO$_2$, but still larger than the respective resistance of the 400°C sample, giving a straightforward explanation of the photocurrent ranking observed for these samples at positive potentials. A further point of discrimination is the rather high trapping resistance $R_{tr}$ of the 600°C sample, which shows the second highest value at potentials more positive than -0.6 V versus Ag/AgCl, succeeding the respective resistance of the 400°C sample. Since this resistance is interpreted in terms of the efficiency of the trapping of holes from the valence band and electrons from the conduction band in surface states, it points to rather small rate constants $k_2$ and $k_4$, respectively, at positive potentials, being in agreement with the slow photocurrent transients of the CLCA measurements (where the magnitude of the decay time constants of the 500°C sample also succeeds the 400°C sample at 0.1 V versus Ag/AgCl). Obviously, this sample exhibits properties that compare better with the 400°C than with the 500°C sample. The XRD pattern points to a strained elementary cell of anatase upon annealing at 600°C, probably in combination with the formation of oxygen-deficient phases. This process is very likely accompanied by the formation of new defects and surface states that can explain the peculiar photoelectro-catalytic properties of this sample.

In conclusion, it could be shown by a combined photocatalytic, antimicrobial and photoelectrochemical study that the respective photoactivities of amorphous and crystalline TiO$_2$ nanolayers can be best correlated, if the extracted photoelectrochemical parameters such as charge transfer and recombination rates, charge transfer efficiencies and resistances, photocurrents as well as IPCE values are measured at potentials close to the OCP. Hence interfacial charge transport parameters at the OCP as determined by photoelectrochemical measurements can be used as descriptors for predicting the photocatalytic activity of TiO$_2$ coatings, too.

**Methods**

**Synthesis of TiO$_2$ thin films**

Titania thin films were prepared by a sol-gel spin-coating method. First, 150.0 mL isopropanol (for analysis, Sigma Aldrich) was cooled in a beaker to about 0°C in a sodium chloride / ice bath. 1.8 mL tetraisopropyl orthotitanate (for synthesis, Sigma Aldrich) was slowly added with a dropping funnel to the stirred solution. Subsequently, 0.5 mL nitric acid (65 %, for analysis, Sigma Aldrich) was cooled in a beaker to about 0°C in a sodium chloride / ice bath. 1.8 mL tetraisopropyl orthotitanate (for synthesis, Sigma Aldrich) was added onto the FTO side (or on the opposite, non FTO-side for GIXRD measurements) of the glass slide while applying the XRD pattern points to a strained elementary cell of anatase upon annealing at 600 °C, probably in combination with the formation of oxygen-deficient phases. This process is very likely accompanied by the formation of new defects and surface states - further supports the presence of a highly reactive surface. In addition, the OCP is slightly more positive than the respective values of the 500 and 600 °C samples, pointing to a lower thermodynamic driving force to participate in redox reactions. In contrast, the highest observed photocurrent at very positive potentials would be in agreement with the lowest charge transfer resistance of all samples. Hence a very high charge transfer rate $k_1$ for direct hole transfer via the valence band to the electrolyte can be expected for this sample.

The 600 °C sample is characterized by a slightly reduced MB degradation rate, a shift of the OCP to more positive values and a lower photocurrent at negative potentials versus Ag/AgCl as compared to the respective values of the 500 °C sample. At negative potentials $k_{ncc}$ is slightly higher than the respective rate constant of the sample annealed at 500 °C. This observation could give rise to a similar explanation in terms of an increased surface hole recombination rate as already discussed for the 400 ° C TiO$_2$. The charge transfer resistance at positive potentials is smaller than the value of the 500 ° C TiO$_2$, but still larger than the respective resistance of the 400 ° C sample, giving a straightforward explanation of the photocurrent ranking observed for these samples at positive potentials. A further point of discrimination is the rather high trapping resistance $R_{tr}$ of the 600 ° C sample, which shows the second highest value at potentials more positive than -0.6 V versus Ag/AgCl, succeeding the respective resistance of the 400 ° C sample. Since this resistance is interpreted in terms of the efficiency of the trapping of holes from the valence band and electrons from the conduction band in surface states, it points to rather small rate constants $k_2$ and $k_4$, respectively, at positive potentials, being in agreement with the slow photocurrent transients of the CLCA measurements (where the magnitude of the decay time constants of the 500 ° C sample also succeeds the 400 ° C sample at 0.1 V versus Ag/AgCl). Obviously, this sample exhibits properties that compare better with the 400 ° C than with the 500 ° C sample. The XRD pattern points to a strained elementary cell of anatase upon annealing at 600 ° C, probably in combination with the formation of oxygen-deficient phases. This process is very likely accompanied by the formation of new defects and surface states that can explain the peculiar photoelectro-catalytic properties of this sample.

In conclusion, it could be shown by a combined photocatalytic, antimicrobial and photoelectrochemical study that the respective photoactivities of amorphous and crystalline TiO$_2$ nanolayers can be best correlated, if the extracted photoelectrochemical parameters such as charge transfer and recombination rates, charge transfer efficiencies and resistances, photocurrents as well as IPCE values are measured at potentials close to the OCP. Hence interfacial charge transport parameters at the OCP as determined by photoelectrochemical measurements can be used as descriptors for predicting the photocatalytic activity of TiO$_2$ coatings, too.
Nabertherm) at 200, 300, 400, 500, and 600°C, respectively.

### Structural characterization

TiO$_2$ nanolayers coated on the FTO-coated side and on the opposite non-FTO-coated side of quartz glass samples, respectively, were analyzed with grazing incidence X-ray diffraction (GIXRD) by using the Malvern Panalytical X'Pert Pro diffractometer with a grazing incidence setup. Cu K$_{α}$ radiation was applied at an operation voltage of 45 kV and a current of 40 mA. Data were collected with an incident angle of 0.5° and with a scan rate of 0.01/s in the 2θ range between 10 and 70°. Field emission scanning electron microscopy (FESEM) and energy-dispersive X-ray spectroscopy (EDX) were performed by preparing cross-sections of the quartz glass/FTO/TiO$_2$ samples and by using a Hitachi S4800 microscope.

### Photodegradation of methylene blue

To determine the degradation rate an aqueous solution of methylene blue (Sigma Aldrich) with a concentration of 10 µmol/L was prepared. To enable a direct comparison with the photoelectrochemical experiments the same light source Zahner LED LS365-2 and photoelectrochemical cell PECC-2 (Zahner) was used for the experiments. 7 mL of the methylene blue solution was inserted into the photoelectrochemical cell PECC-2, which also contained the uncoated and TiO$_2$-coated FTO glass slides, respectively. The irradiation experiments were executed inside a light-exclusion box. After a waiting and equilibration time of 30 minutes - in order to minimize adsorption effects - a first 2.5 mL sample of the methylene blue solution in the PECC-2 was taken with a syringe and inserted into a 1 cm quartz cuvette. The absorbance of the sample at 664 nm was measured immediately in the UV-Vis spectrometer Specord 200 (Analytik Jena). This value served as reference for all the following measurement points after irradiation to obtain the relative concentration c/c$_0$ in dependence on irradiation time. Subsequently, the methylene blue sample was transferred back into the PECC-2, and the irradiation of the glass slide in the PECC-II was started by using the calibrated LED LS365-2 (Zahner) at a potentiostat / silicon diode sensor controlled light intensity of 1000 W/m$^2$. 2.5 mL samples of the methylene blue solution in the PECC-2 were taken every two minutes irradiation time to measure the absorbance in dependence of irradiation time as described before. During sampling and measuring absorption spectra, the light source was turned off to stop further light-induced degradation in the photoelectrochemical cell. After the absorption measurement, the sample was subsequently transferred back into the PECC-2 again, the LED was turned on again and this procedure was repeated until a total irradiation time of 20 minutes was reached. All degradation curves for each sample were measured three times with fresh methylene blue solution to calculate the mean and the standard error.

### Photocatalytic antibacterial activity tests

Escherichia coli XL1-Blue strain was used as model organism to assess the antimicrobial properties of TiO$_2$-coated FTO glass slides. For this study test series with uncoated and TiO$_2$-coated FTO glass slides calcined at 300 and 500°C, respectively, were investigated. Overnight cultures of E. coli bacteria were grown in 5 mL Luria Bertani (LB) agar at 38°C. The investigated FTO glass slides were sterilized for 1.5 hours at 180°C. Subsequently, 50 µL of the E. coli overnight culture (100 times diluted with LB medium) was added onto the glass slides and evenly distributed with an inoculating loop. The bacteria-coated glass slides were placed in the Vilber CN-6 dark room and irrigated with the UV-A lamp VL-6.L (6 W power, Vilber) exhibiting a peak wavelength of 365 nm. Non-irradiated glass slides of each test series analyzed after 120 min in the dark served as control. For each test series glass slides were removed from the dark/UV chamber after 30, 60, 90, and 120 min, respectively. The surviving bacteria on the glasses after each irradiation time series were immediately collected by purging the glass slides with 450 µL of an aqueous sodium chloride solution (0.9 %) into a Petri dish. The procedure was repeated four times using always the same purge solution. The received purge solution was diluted with 4.05 mL aqueous sodium chloride solution (0.9 %) and cultured on agar plates for 24 hours at 38°C. The number of surviving bacteria was counted and is expressed as the logarithm of the ratio (survival ratio) of the number of viable bacteria remaining after exposure to experimental conditions (S) to the number of the initial viable bacteria (S$_0$) (log S/S$_0$).

### Photoelectrochemical characterization

Photoelectrochemical measurements were utilized with a Zahner Zennium electrochemical workstation in connection with a Zahner PP211 potentiostat for light control. The investigated FTO glass slide was contacted as working electrode with a stainless steel mesh in a Teflon-based gas-tight photoelectrochemical cell PECC-2 (Zahner) in transparent working electrode configuration with two quartz windows. For the standard three electrode configuration a platinum wire was used as counter electrode and all potentials were measured against and referred to a Ag/AgCl reference electrode. Due to the geometry of the cell a constant circular area with a diameter of 1.8 cm of the glass sample was always irradiated. All electrochemical measurements were carried out in aqueous 1.0 M NaOH electrolyte. After installing the glass slide into the photoelectrochemical cell, but before the electrochemical measurements, the electrolyte was deaerated with nitrogen gas. The photoelectrochemical studies were performed in the dark and with a calibrated UV light LED (LS365-2; dominant wavelength $λ = 369$ nm) providing DC light intensities up to 2000 W/m$^2$, respectively. The incident light intensity was controlled with a calibrated silicon diode.
photosensor. The sensor output was fed into the Zahner Zennium / Potentiostat PP211 control loop for controlling the light intensity and modulation of the LED. All photoelectrochemical experiments were performed inside a light-exclusion box / Faraday cage.

References


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**Author contributions statement**

M.E. conceived the experiments, V.S. and U.H. conducted the experiments, V.S., U.H., and M.E. analysed the results. M.E. wrote the main manuscript text and prepared all figures. All authors reviewed the manuscript.

**Competing interests**

The authors declare no competing interests.
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